



**REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 4649**

Attorney Docket No.: 040258/0279274
Client Reference: EL01001CDC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
HONGO *et al.*

Confirmation No. 4649

Application No.: **09/815,305**

Filed: March 23, 2001

ART UNIT: 1763

Title: PLASMA PROCESSING APPARATUS
HAVING AN EVACUATING ARRANGEMENT TO
EVACUATE GAS FROM A GAS-INTRODUCING
PART OF A PROCESS CHAMBER

Examiner: ALEJANDRO, M. L.

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January 7, 2005

**AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116
WITH REQUEST FOR CONTINUED EXAMINATION**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated August 10, 2004, a response to which is due January 10, 2005 with the payment of a two-month extension fee, please amend the above-identified application as follows.

01/10/2005 ZJU HAR1 00000077 033975 09815305
02 FC:1252 450.00 DA